

JFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(211.001-D3-US)

In re Application of: **FAZAN ET AL.**)
Serial No: **10/724,648**) Group Art Unit: **2814**
U.S. Filing Date: **DECEMBER 1, 2003**) Examiner:
Title: **SEMICONDUCTOR DEVICE**)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 26, 2004
Date
Michiko Sites
(person signing this certificate)
Michiko Sites
Signature

SECOND PRELIMINARY AMENDMENT

Dear Sir:

Preliminary to the examination of the above-referenced application, kindly amend the application as follows: